



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SP01-319

2874
#3
04/14/03

Applicant: Robert A. Boudreau, et al
Serial No: 10/016,113
Filed: 11/2/2001
For: SILICON WAFERBOARD

Examiner:
Group Art Unit: 2874

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 - 1.98

Asst. Commissioner of Patents and Trademarks
Washington, DC 20231

Dear Sir:

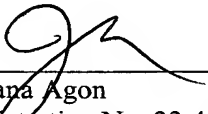
The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

Each of the enclosed reference(s) was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

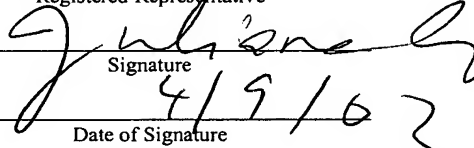
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,


Juliana Agon
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Date: 4/9/03

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Asst. Commissioner of Patents and Trademarks, Washington, D.C. 20231	
on	<u>4/9/03</u>
Date of Deposit	
<u>Juliana Agon</u>	
Name of applicant, assignee, or Registered Representative	
	
Signature	
<u>4/9/03</u>	
Date of Signature	

SP01-319



FORM PTO-1449 (MODIFIED)

ATTORNEY DOCKET NO.

SERIAL NO.

SP01-319

10/016113

LIST OF PATENTS AND
PUBLICATIONSFOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

APPLICANT Robert A. Boudreau, et al.

FILING DATE 11/2/2001

GROUP: 2874

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date if Approp.
	AA	4,826,272	5/2/89	Pimpinella, et al	350	96.20	
	AB	5,247,597	9/21/93	Blacha, et al	385	88	
	AC	6,483,969B1	11/19/02	Yap, et al	385	52	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub- Class	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	
	AS	
	AT	
	AU	
	AV	
	AW	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.